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| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. |
|--|----------------|----------------------|-----------------------------------|------------------|
| 10/825,831 | 04/16/2004 | Sudhir Gondhalekar | 007728 9468 USAP01/DSM/HDP/CVD | |
| 61285 7 | 590 05/31/2006 | | EXAMINER | |
| JANAH & ASSOCIATES, P.C. 650 DELANCEY STREET, SUITE 106 | | | ZERVIGON, RUDY | |
| SAN FRANCISCO, CA 94547 | | | ART UNIT | PAPER NUMBER |
| | , | | 1763 | |
| | | | DATE MAILED: 05/31/2006 | 6 |

Please find below and/or attached an Office communication concerning this application or proceeding.

| | Application No. | Applicant(s) | | | | |
|--|---|--|--|--|--|--|
| Off: A - 4' O | 10/825,831 | GONDHALEKAR ET AL. | | | | |
| Office Action Summary | Examiner | Art Unit | | | | |
| | Rudy Zervigon | 1763 | | | | |
| The MAILING DATE of this communication app Period for Reply | pears on the cover sheet with t | the correspondence address | | | | |
| A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | ATE OF THIS COMMUNICAT 36(a). In no event, however, may a reply will apply and will expire SIX (6) MONTHS a, cause the application to become ABAND | FION. be timely filed from the mailing date of this communication. DONED (35 U.S.C. § 133). | | | | |
| Status | | | | | | |
| 1)⊠ Responsive to communication(s) filed on 14 M | <u>farch 2006</u> . | | | | | |
| 2a)⊠ This action is FINAL . 2b)☐ This | This action is FINAL . 2b) This action is non-final. | | | | | |
| 3) Since this application is in condition for alloward | Since this application is in condition for allowance except for formal matters, prosecution as to the merits is | | | | | |
| closed in accordance with the practice under E | Ex parte Quayle, 1935 C.D. 1 | 1, 453 O.G. 213. | | | | |
| Disposition of Claims | | | | | | |
| 4)⊠ Claim(s) <u>1,3-11,13-15 and 17-20</u> is/are pendin | ig in the application. | | | | | |
| 4a) Of the above claim(s) is/are withdraw | 4a) Of the above claim(s) is/are withdrawn from consideration. | | | | | |
| 5) Claim(s) is/are allowed. | | | | | | |
| 6) Claim(s) <u>1,3-11,13-15 and 17-20</u> is/are rejecte | | | | | | |
| 7) Claim(s) is/are objected to. | | | | | | |
| 8) Claim(s) are subject to restriction and/o | r election requirement. | | | | | |
| Application Papers | | | | | | |
| 9) The specification is objected to by the Examine | er. | | | | | |
| 10)⊠ The drawing(s) filed on 16 April 2004 is/are: a) |)⊠ accepted or b)□ objected | d to by the Examiner. | | | | |
| Applicant may not request that any objection to the | | | | | | |
| Replacement drawing sheet(s) including the correct | | • • | | | | |
| 11)☐ The oath or declaration is objected to by the Ex | caminer. Note the attached Of | ffice Action or form PTO-152. | | | | |
| Priority under 35 U.S.C. § 119 | | | | | | |
| 12) Acknowledgment is made of a claim for foreigna) All b) Some * c) None of: | priority under 35 U.S.C. § 11 | 9(a)-(d) or (f). | | | | |
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| | | | | | | |
| 3. Copies of the certified copies of the prior | rity documents have been rec | ceived in this National Stage | | | | |
| application from the International Bureau | 1 11 | | | | | |
| * See the attached detailed Office action for a list | of the certified copies not rec | eived. | | | | |
| | | | | | | |
| Attachment(s) | | · | | | | |
| 1) Notice of References Cited (PTO-892) | 4) Interview Sumr | mary (PTO-413) | | | | |
| 2) D Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Ma | ail Date | | | | |
| 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date | 6) Other: | nal Patent Application (PTO-152) | | | | |
| | | | | | | |

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DETAILED ACTION

Claim Rejections - 35 USC § 103

1. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 1, 3-11, 13-15, 17-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over McMillin; Brian et al. (US 6,013,155 A) in view of Rohrberg; Roderick (US 3,604,889 A). McMillin teaches a replaceable gas nozzle (180; Figure 1; column 6; line 66 - column 7, line 18) that is insertable in a gas distributor ring (170; Figure 2a,b; column 6; line 66 - column 7, line 18) of a substrate processing chamber (140; Figure 1; column 6; lines 44-65) and that can be shielded within the chamber (140; Figure 1; column 6; lines 44-65), the gas nozzle (180; Figure 1; column 6; line 66 - column 7, line 18) comprising: a longitudinal ceramic body (180; Figures 12a,b; 13a,b) having a channel (conduit not labelled; Figures 12a,b; 13a,b) to direct the flow of the gas into the chamber (140; Figure 1; column 6; lines 44-65), the channel (conduit not labelled; Figures 12a,b; 13a,b) comprising an inlet to receive the gas from the gas distributor ring (170; Figure 2a,b; column 6; line 66 - column 7, line 18), and a pinhole outlet at the end of the channel (conduit not labelled; Figures 12a,b; 13a,b) to release the gas into the chamber (140; Figure 1; column 6; lines 44-65) – claim 1

McMillin further teaches:

i. A nozzle (180; Figure 1; column 6; line 66 - column 7, line 18) according to claim 1 wherein the ceramic body (180; Figure 1) is composed of aluminum oxide (column 6; line 66 - column 7, line 18), as claimed by claim 5

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McMillin does not teach a second external thread to receive a heat shield. McMillin does not teach ceramic body (180; Figure 1) comprising a first external thread to mate with the gas distributor ring (170; Figure 2a,b; column 6; line 66 - column 7, line 18).

McMillin further does not teach:

- i. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 1 wherein the pinhole outlet has a diameter d_o, and wherein the distance dst between the second external thread and the pinhole outlet is about 90 d_o to about 140 d_o., as claimed by claim 1
- ii. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 2 wherein do is from about 0.3 mm to about 0.4 mm, as claimed by claim 3
- iii. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 2 wherein dst is from about 30 mm to about 55 mm, as claimed by claim 4
- iv. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 1 wherein the ceramic body (180; Figure 1) is composed of aluminum nitride, as claimed by claim 6
- v. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 1 wherein the ceramic body (180; Figure 1) tapers at an angle from about 35 to about 45° to the pinhole outlet, as claimed by claim 7
- vi. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 1 further comprising a heat shield mounted on the second external thread, as claimed by claim 8

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- vii. a heat shield for shielding a nozzle (180; Figure 1; column 6; line 66 column 7, line 18) extending into a chamber (140; Figure 1; column 6; lines 44-65) to introduce a process gas into the chamber (140; Figure 1; column 6; lines 44-65) through a nozzle (180; Figure 1; column 6; line 66 column 7, line 18) outlet, wherein the chamber (140; Figure 1; column 6; lines 44-65) defines a processing region therein and has a substrate support (130; Figure 2a) to support (130; Figure 2a) a substrate for processing in the chamber (140; Figure 1; column 6; lines 44-65), the heat shield comprising: a hollow member configured to be coupled with McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) and having an internal dimension sufficiently large to be disposed around at least a portion of McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18), the hollow member having an extension which projects distally of McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) outlet and which includes a heat shield opening for the process gas to flow therethrough from McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) outlet, as claimed by claim 9
- viii. The heat shield of claim 3 wherein the hollow member is cylindrical and has an internal cross-section which is larger than an external cross-section of McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) by about an amount smaller than the thickness of the heat shield, as claimed by claim 10
- ix. The heat shield of claim 3 wherein the hollow member comprises a ceramic material, as claimed by claim 11
- x. The heat shield of claim 3 wherein the extension of the heat shield is sized to project distally of McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) outlet

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by a distance of between about a radius of McMillin's nozzle (180; Figure 1; column 6; line 66 - column 7, line 18) and about a diameter of McMillin's nozzle (180; Figure 1; column 6; line 66 - column 7, line 18), as claimed by claim 9

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- xi. a heat shield according to claim 5 wherein the ceramic material comprises aluminum oxide (column 6; line 66 column 7, line 18) or aluminum nitride, as claimed by claim 13
- xii. a heat shield according to claim 6 wherein the extension projects distally by about 5 mm to about 8 mm, as claimed by claim 14
- xiii. the shielded gas nozzle (180; Figure 1; column 6; line 66 column 7, line 18) for a substrate processing chamber (140; Figure 1; column 6; lines 44-65) comprising: (a) a longitudinal ceramic body (180; Figures 12a,b; 13a,b) having a channel (conduit not labelled; Figures 12a,b; 13a,b) to direct the flow of the gas into the chamber (140; Figure 1; column 6; lines 44-65), the ceramic body (180; Figure 1) comprising a first external thread to mate with the gas distributor ring (170; Figure 2a,b; column 6; line 66 column 7, line 18), a second external thread to receive a heat shield, the channel (conduit not labelled; Figures 12a,b; 13a,b) comprising an inlet to receive the gas from the gas distributor ring (170; Figure 2a,b; column 6; line 66 column 7, line 18), and a pinhole outlet at the end of the channel (conduit not labelled; Figures 12a,b; 13a,b) to release the gas into the chamber (140; Figure 1; column 6; lines 44-65). (b) a hollow member configured to be coupled with the ceramic body (180; Figure 1) and having an internal dimension sufficiently large to be disposed around at least a portion of the ceramic body (180; Figure 1), the hollow member having an extension which projects distally of the

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pinhole outlet and which includes a heat shield opening for the process gas to flow therethrough from the pinhole outlet, as claimed by claim 15

- xiv. McMillin's nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 1 wherein the pinhole outlet has a diameter do, and wherein the distance dst between the second external thread and the pinhole outlet is about 90 do to about 140 do, as claimed by claim 15
- xv. The shielded gas nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 15 wherein the hollow member is cylindrical and has an internal cross-section which is larger than an external cross-section of the ceramic body (180; Figure 1) by about an amount smaller than the thickness of the hollow member, as claimed by claim 17
- xvi. The shielded gas nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 15 wherein the extension of the hollow member is sized to project distally of the pinhole outlet by a distance of between about a radius of the ceramic body (180; Figure 1) and about a diameter of the ceramic body (180; Figure 1), as claimed by claim 18
- xvii. the shielded gas nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 15 wherein the ceramic body (180; Figure 1) and hollow member are composed of aluminum oxide (column 6; line 66 column 7, line 18), as claimed by claim 19
- xviii. the shielded gas nozzle (180; Figure 1; column 6; line 66 column 7, line 18) according to claim 15 wherein the ceramic body (180; Figure 1) and the hollow member are composed of aluminum nitride, as claimed by claim 20

Rohrberg teaches a double threaded gas nozzle (40; Figure 1) including a shield (22,20,24; Figure 1) for said nozzle.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to replace McMillin's gas nozzle with Rohrberg's double threaded gas nozzle and shield, inclusive, for Rohrberg to optimize the dimensions and materials of his apparatus.

Motivation to replace McMillin's gas nozzle with Rohrberg's double threaded gas nozzle and shield, inclusive, for Rohrberg to optimize the dimensions and materials of his apparatus is for unifromly distributing process gas over a process area as taught by Rohrberg (column 3, lines 51-66). Further, it is well established that changes in apparatus dimensions are within the level of ordinary skill in the art. (Gardner v. TEC Systems, Inc., 725 F.2d 1338, 220 USPO 777 (Fed. Cir. 1984), cert. denied, 469 U.S. 830, 225 USPQ 232 (1984); In re Rose, 220 F.2d 459, 105 USPQ 237 (CCPA 1955); In re Rinehart, 531 F.2d 1048, 189 USPQ 143 (CCPA 1976); See MPEP 2144.04). Further, it is well settled that the intended uses of and the particular material used in a coating apparatus have no significance in determining patentability of apparatus claims. (Ex parte Thibault, 164 U.S.P.Q. 666 (Bd. Pat. App. 1969), MPEP 2116).

Response to Arguments

- Applicant's arguments filed March 14, 2006 have been fully considered but they are not 3. persuasive.
- 4. Applicant states that none of the cited prior art teach or suggest applicant's claim amenment limitation of "wherein the pinhole outlet has a diameter do, and wherein the distance dst between the second external thread and the pinhole outlet is about 90 do to about 140 do." as claimed by independent claims 1, 9, and 15.

In response, the Examiner agrees, however, the Examiner clearly stated that it would ... for Rohrberg to optimize the dimensions and materials of his apparatus. As a result the Examiner concludes that the only difference between the claimed invention and the apparatus of the prior art is a recitation of relative dimensions of the claimed components. Further, it is well established that changes in apparatus dimensions are within the level of ordinary skill in the art.

Conclusion

5. Applicant's amendment necessitated the new grounds of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Examiner Rudy Zervigon whose telephone number is (571) 272-1442. The examiner can normally be reached on a Monday through Thursday schedule from 8am through 7pm. The official fax phone number for the 1763 art unit is (571) 273-8300. Any Inquiry of a general nature or relating to the status of this application or proceeding should be directed to

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the Chemical and Materials Engineering art unit receptionist at (571) 272-1700. If the examiner can not be reached please contact the examiner's supervisor, Parviz Hassanzadeh, at (571) 272-1435.

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